

Form PTO-1449
(Rev. 8-88)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: 1115.64887

Serial No.:

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Applicant: Jongill et al.

Filing Date: November 30, 2000

Group:

Jc966 U.S. PTO
09/12/03

11/30/00

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
W4	10041561	Feb. 13, 1998	Japan			Abs.	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Date Considered

*Examiner:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-88)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: 1115.64887

Serial No.: 09/726,752

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Applicant: Jongill et al.

Filing Date: 11-30-2000

Group: 1773

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
754	490 608	Jun. 17, 1992	Europe			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

754	J.J. deVries et al.; "Oscillatory Interlayer Exchange Coupling with the Cu Cap Layer Thickness in Co/Cu/Co/Cu(100)"; <i>Physical Review Letters</i> ; Vol. 75, No. 23; pp. 4306-4309; Dec. 4, 1995.
754	T.R. McGuire et al.; "Magnetoresistance and exchange effects of NiCo/Cu sandwich films with oxide overlayer"; <i>Journal of Applied Physics</i> ; Vol. 75, No. 10, Part 2B, pp. 6537-6539; May 15, 1994.
754	K. Matsuyama et al.; "Perpendicular spin valve behavior in a microstructrued Co/Cu-Cu oxide/Co trilayer"; <i>Journal of Applied Physics</i> ; Vol. 79, No. 8, Part 2A, pp. 5318-5320; April 15, 1996.

Examiner

Date Considered

*Examiner:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449 U.S. Department of Commerce
(Rev. 8-88) Patent and Trademark Office

Attorney Docket No.: 1115.64887

Serial No.: 09/726,752

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Applicant: Jongill et al.

Filing Date: 11-30-2000

Group: 1773

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

JW	Jongill Hong et al.; "Effect of Thin Oxide Capping on Interlayer Coupling in Spin Valves"; IEEE Transactions on Magnetics, Vo. 36, No. 5, pp. 2629-2631; September 2000.

Examiner

Date Considered

*Examiner:

(Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.